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CONFIRMATION NO. 2871

SERIAL NUMBE 10/822,722			CLASS 438		GROUP ART UNIT 2891			ATTORNEY OOCKET NO. 60188-834	
APPLICANTS									
Kenji Yoneda, Kyoto, JAPAN;									
** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/23/2004									
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Examiner's Signature Initials				STATE OR	SHEE	rs to	TAL	INDEPENDENT	
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ADDRESS Jack Q. Lever, Jr. McDERMOTT, WILL & EMERY 600 Thirteenth Street, N.W. Washington, DC 20005-3096									
TITLE Method for fabricating semiconductor device and semiconductor substrate									
FILING FEE FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT PECSIVED No for following:									
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